

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) :	Dureseti CHIDAMBARRAO	Group Art Unit: 2813
Appln. No. :	10/715,400	Examiner: J. M. Mitchell
Filed :	November 19, 2003	Confirmation No.: 5307
For :	SILICON DEVICE ON Si:C-OI AND SGOI AND METHOD OF MANUFACTURE	

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. §1.112

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria VA 22314

Sir:

In response to the Office Action dated October 11, 2006, please reconsider the above-identified application in view of the following:

A listing of claims begins on page 2.

Remarks begin on page 9.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.